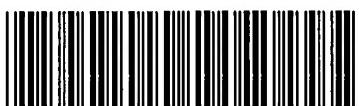


Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10550238	KIM ET AL.
Examiner	Art Unit	
Heyman, John	2871	

SEARCHED

Class	Subclass	Date	Examiner
349	106, 108, 109	06/26/2007	JSH
349	106, 108, 109	11/01/2007	JSH

SEARCH NOTES

Search Notes	Date	Examiner
Consult Primary Ex'r Andrew Scechter	06/26/2007	JSH

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner
349	See search history	11/01/2007	JSH